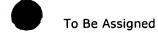
Application No.:





<u>ABSTRACT</u>

A method of manufacturing plasma display panels using a substrate holder for deposition on a substrate of the plasma display panel. The substrate holder is configured with plural frames, and the substrate of the plasma display panel is held by its periphery with at least one of these frames. A frame holding the substrate has a protrusion extending to a non-deposition face of the substrate held in such a way as to surround the substrate. Since the protrusion acts as a blocking sheet, attachment of a deposition material passing through an opening on the substrate holder and reaching onto the non-deposition face of the substrate is suppressed.